

Application/Control No.	Applicant(s)/Patent under Reexamination
10/565,394	KOBAYASHI ET AL.
Examiner	Art Unit
Hau V. Phan	3618

SEARCHED				
Class	Subclass	Date	Examiner	
180	89.2 309	9/12/2007	HP	
	296			
	219			
181	250	9/12/2007	HP	
	207			
	273			
	227			
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60	322	9/12/2007	HP	
	299			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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